



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 16, 2026	
IGI Report Number	LG801623529
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUSHION MODIFIED BRILLIANT
Measurements	9.59 X 7.06 X 4.74 MM

GRADING RESULTS

Carat Weight	2.51 CARATS
Color Grade	F
Clarity Grade	VS 1

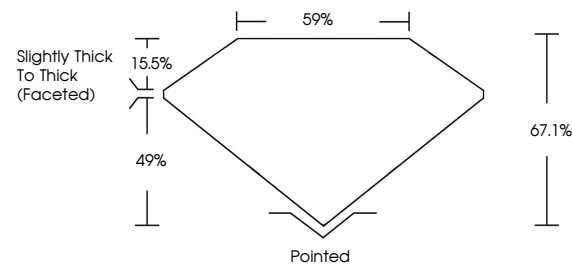
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG801623529

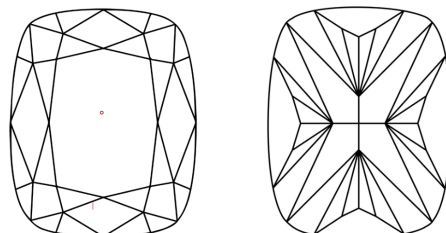
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG801623529
Report verification at igi.org

PROPORTIONS

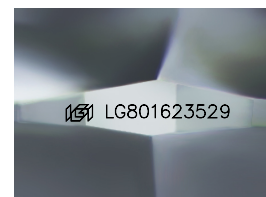


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

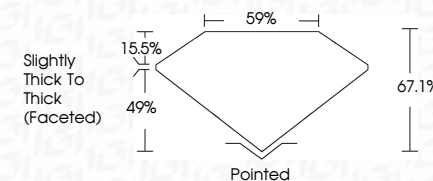
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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May 14, 2026	VS 1	Polished
G1 Report No. LG801623529	67.1%	EXCELLENT
CUSHION MODIFIED BRILLIANT	59%	EXCELLENT
	Slightly Thick to Thick (Faceted)	NONE
		681 LG801623529

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Type IId